

DECLARATION OF JOINT INVENTORS FOR PATENT APPLICATION

As the below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name.

I believe I am the original, first and joint inventor of the subject matter which is claimed and for which a patent is sought on the invention entitled: Compositions Of Matter, Semiconductor Devices, And Semiconductor Processing Methods, the specification of which is attached hereto.

I hereby state that I have reviewed and understand the contents of the above-identified specification, including the claims.

I acknowledge the duty to disclose information known to me to be material to patentability as defined in Title 37, Code of Federal Regulations §1.56.

PRIOR FOREIGN APPLICATIONS:

I hereby state that no applications for foreign patents or inventor's certificates have been filed prior to the date of execution of this declaration.

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so

1 made are punishable by fine or imprisonment, or both, under
2 Section 1001 of Title 18 of the United States Code and that such willful
3 false statement may jeopardize the validity of the application or any
4 patent issued therefrom.

5 * * * * *

6 Full name of inventor: Weimin Li

7 Inventor's Signature: 

8 Date: 12/9/98

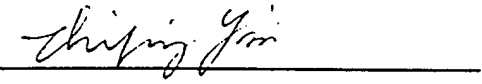
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14 Full name of inventor: Zhiping Yin

15 Inventor's Signature: 

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